

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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## Title of Invention

POLISHING INHIBITING LAYER FORMING ADDITIVE,  
SLURRY AND CMP METHOD

Application Number :

Confirmation Number:

First Named Applicant: Michael MacDonald

Attorney Docket Number: FIS920040163

Art Unit:

Examiner:

Search string: ( 6514862 ).pn

## US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6514862	2003-02-04	Lee et al.			

## Signature

Examiner Name	Date